

Electronic Supporting Information (ESI)

High-performance UV-activated room temperature NO₂ sensors based on TiO₂/In₂O₃ composite

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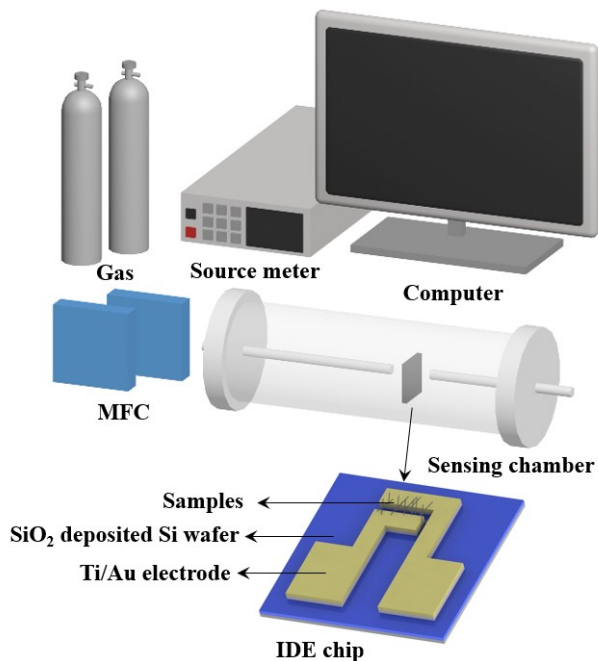
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S1. The IDE chip with 10 nm Ti adhesion layer and 100 nm Au conduction layer on SiO₂-deposited Si wafer substrate and homemade gas sensing system.

Sample	In 3d _{5/2} binding energy (eV)	In 3d _{3/2} binding energy (eV)	Ti 2p _{3/2} binding energy (eV)	Ti 2p _{1/2} binding energy (eV)
S0	444.93	452.47	-	-
S1	444.61	452.15	457.29	462.83
S2	444.42	451.96	457.31	462.85
S3	443.90	451.44	257.98	463.52

Table 1. Binding energies of the In 3d and Ti 2p peaks for different samples determined using XPS.

Sample	O_{lattice} binding energy (eV)	O_{vac} binding energy (eV)	O_{abs} binding energy (eV)	O_{lattice} percentage (%)	O_{vac} percentage (%)	O_{abs} percentage (%)
S0	529.36	530.96	532.16	76.02	19.70	4.28
S1	530.29	531.90	533.10	66.15	24.62	9.23
S2	530.23	531.94	533.07	59.87	38.08	2.05
S3	530.20	531.80	533.01	65.02	28.33	6.65

Table 2. Binding energies and proportions of the three components of the O 1s peak for different samples determined using XPS.

Material	Temperature (°C)	Concentration (ppm)	Response	Refs.
In ₂ O ₃ /rGO	RT	30	8.25	[1]
Walnut-like In ₂ O ₃	RT	3	13	[2]
Mesoporous In ₂ O ₃ nanorod arrays	RT	1	20.9	[3]
In ₂ O ₃ /ZnO	RT	10	29.1	[4]
In ₂ O ₃ /ZnO YS NFs	RT	1	6	[5]
TiO ₂ /In ₂ O ₃ NFs	RT	5	49.29	This work

Table 3. Comparison of the NO₂ sensing properties of previously reported In₂O₃-based nanostructures and TiO₂/In₂O₃ NFs of the present study at RT.

References

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